

10057 U.S. PTO  
10/051375  
01/17/03

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# U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM 10051375	FILING DATE 01/17/2002	CLASS 372	SUBCLASS -	GAU 2821	EXAMINER -
<b>**APPLICANTS:</b> Eom Tae Suh Ho Choi Tae					
<b>**CONTINUING DATA VERIFIED:</b>					
<b>** FOREIGN APPLICATIONS VERIFIED:</b> REPUBLIC OF KOREA 2001 48463 08/11/2001 REPUBLIC OF KOREA 2001 52030 08/22/2001					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 110 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiner's initials				ATTORNEY DOCKET NO PAS202A	
<b>TITLE:</b> Nonlinearity error correcting method and phase angle measuring method for displacement measurement in two-frequency laser interferometer and displacement measurement system using					

<b>NOTICE OF ALLOWANCE MAILED</b>		Assistant Examiner	<b>CLAIMS ALLOWED</b>	
			Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		Primary Examiner	<b>DRAWING</b>	
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		PREPARED FOR ISSUE	Application Examiner	
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